

Supplementary Information for

## **Thin All-Elastomeric Capacitive Pressure Sensor Array Based on Micro Contact Printed Elastic Conductors**

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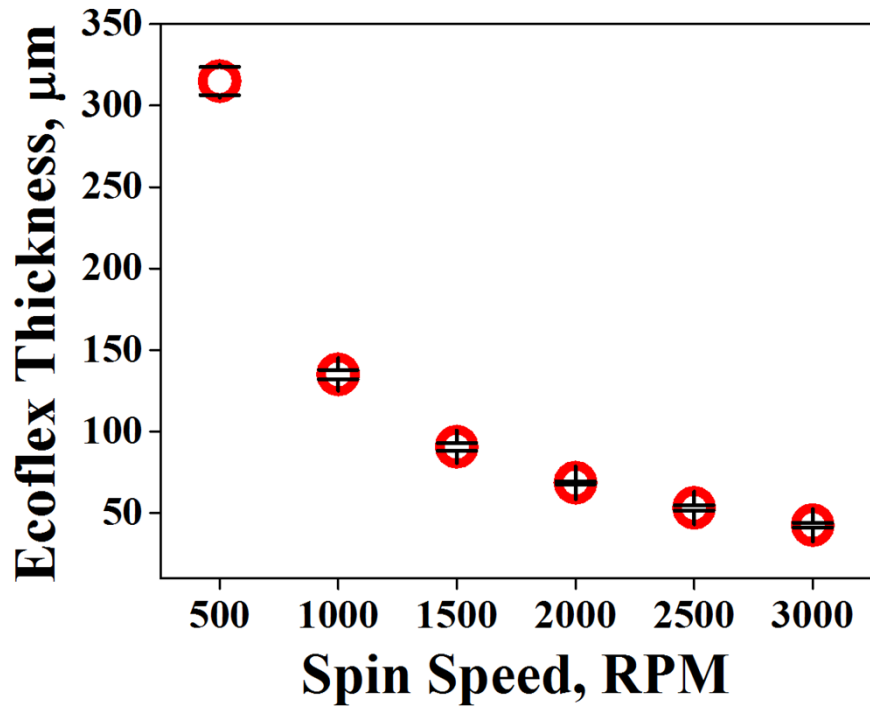


Fig. S1 Thickness variations of Ecoflex layer as a function of spin speed.

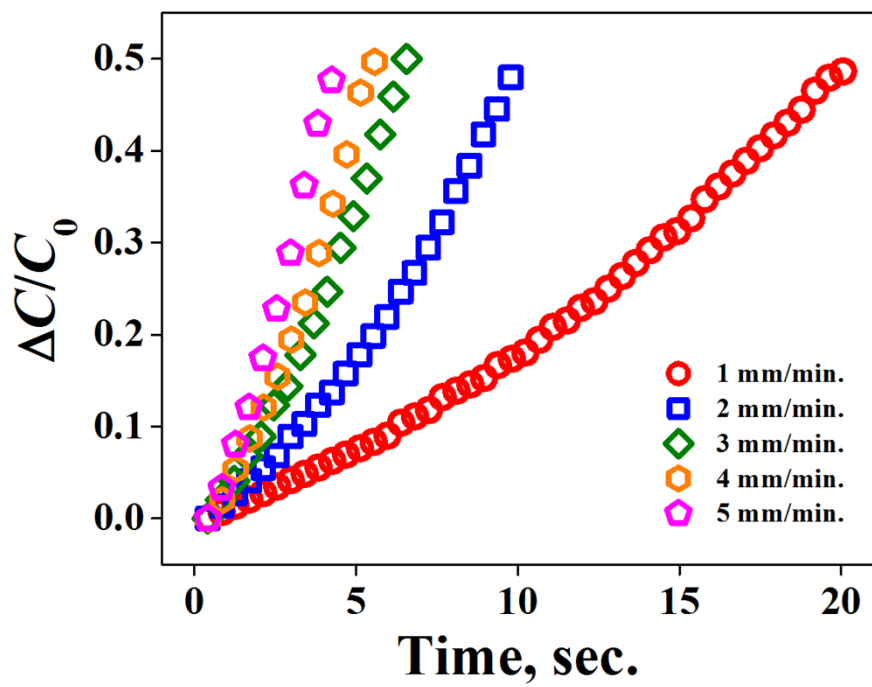


Fig. S2 Slopes in capacitance change ratio under various loading speeds with fixed maximum loading pressure of  $\sim 0.8$  Mpa.